

DOCKET NO: 230421US26YA

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
ANDREJ S. MITROVIC : EXAMINER: SAXENA, AKASH
SERIAL NO: 10/673,501 :
FILED: SEPTEMBER 30, 2003 : GROUP ART UNIT: 2128
FOR: SYSTEM AND METHOD FOR :
USING FIRST-PRINCIPLES
SIMULATION TO CHARACTERIZE A
SEMICONDUCTOR MANUFACTURING
PROCESS

AMENDMENT UNDER 37 C.F.R. § 1.111

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In a reply to the Office Action dated December 23, 2010, please amend the above-identified application as follows:

Amendments to the Claims begins on page 2 of this paper.

Amendments to the Drawings begin on page 13 of this paper and include an attached replacement sheet.

Remarks/Arguments begin on page 14 of this paper.